

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 53080  
Kunimasa TAKAHASHI, et al. : Confirmation Number: 6282  
Patent No.: 7,462,540 B2 : Issue Date: December 9, 2008  
Application No.: 10/553,845 : Group Art Unit: 2813  
Filed: October 20, 2005 : Examiner: Laura M. MENZ  
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND PROCESS FOR PRODUCING  
THE SAME

**REQUEST FOR CERTIFICATE OF CORRECTION UNDER 37 CFR 1.322**

Mail Stop Certificate of Correction  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reviewing the above-identified patent, a printing error was discovered therein requiring correction in order to conform the Official Record in the application.

The error noted is set forth on the attached copy of form PTO-1050 Rev. 2-93 in the manner required by the Commissioner's Notice.

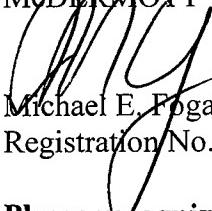
Specifically, on the title page of the patent, under Item "(56) References Cited", under FOREIGN PATENT DOCUMENTS, delete "JP 2002-012482 1/2000"; and change "JP 2002-089551 10/2002" to --JP 2002-289551 10/2002--. Attached, please find copies of the Information Disclosure Statements dated October 6, 2008 and October 20, 2005, which show the correct reference numbers. Also attached are copies of the 1449 forms which indicate the correct reference numbers and are initialed by the Examiner.

The change requested herein occurred as a result of printing the Letters Patent and the Certificate should be issued without expense under Rule 322 of the Rules of Practice. Accordingly, Applicants request issuance of the Certificate of Correction.

Please charge any shortage in fees due in connection with the filing of this paper to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

  
Michael E. Fogarty  
Registration No. 36,139

**Please recognize our Customer No. 53080  
as our correspondence address.**

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
Phone: 202.756.8000 MEF:alb  
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**Date: March 17, 2009**

WDC99 1697676-1.071971.0390

**UNITED STATES PATENT AND TRADEMARK OFFICE**  
**CERTIFICATE OF CORRECTION**

PATENT NO : 7,462,540

Page 1 of 1

APPLICATION NO. : 10/553,845

ISSUE DATE : December 09, 2008

INVENTOR(S) : Kunimasa TAKAHASHI, et al.

It is certified that an error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the title page of the patent, under Item "(56) References Cited", under FOREIGN PATENT DOCUMENTS, delete "JP 2002-012482 1/2000"; and  
Change "JP 2002-089551 10/2002" to --JP 2002-289551 10/2002--.

## MAILING ADDRESS OF SENDER (Please do not use customer number below):

600 13th Street, N.W.  
Washington, D. C. 20005-3096

This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: ATTENTION Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



Docket No.: 071971-0390

93 IPW  
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 53080  
Kunimasa TAKAHASHI, et al. : Confirmation Number: 6282  
Application No.: 10/553,845 : Group Art Unit: 2813  
Filed: October 20, 2005 : Examiner: Kayra Nart NEBZ  
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR PRODUCING  
THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

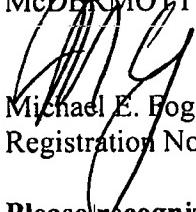
This Information Disclosure Statement is being submitted to correct typographical errors in the Form 1449 originally Submitted on October 20, 2005. The Japanese reference originally listed as JP 2002-012482 should read **JP 2000-012482**. Please note that a copy of the correct reference, JP 2000-012482 was submitted with the original information disclosure statement filed on October 20, 2005. A corrected PTO-Form 1449 is being filed herewith.

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

  
Michael E. Fogarty  
Registration No. 36,139

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600 13<sup>th</sup> Street, N.W.  
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**Date: October 6, 2008**



SHEET 1 OF 1

**\*EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.  
Include copy of this form with next communication to applicant.  
1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

10/553845

JCO9 Rec'd PCT/PTO 20 OCT 2005,

Docket No.: 071971-0390

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
Kunimasa TAKAHASHI, et al. : Confirmation Number: Not yet assigned  
assigned : Group Art Unit: Not yet assigned  
Application No.: Not yet assigned : Examiner: Not yet assigned  
Filed: October 20, 2005 :  
  
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR  
FABRICATION THE SAME

**INFORMATION DISCLOSURE STATEMENT**

Honorable Commissioner for Patents and Trademarks  
Washington, D. C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the application and no certification or fee is required.

A copy of the foreign search report is attached for the Examiner's information. Please note this is a PCT application in the entry of the National Phase in the U.S. and copies of the references cited were transmitted by WIPO and are believed to be in the file of the above identified application and readily available to the Examiner. Therefore it is

10/553845

Not yet assigned

JC09 Rec'd PCT/PTO 20 OCT 2005

believed that Applicants have met all requirements regarding duty of disclosure under 37 CFR 1.56. Acknowledgement and consideration of these documents are respectfully requested.

A copy of the foreign search report is attached for the Examiner's information. Please note this is a PCT application in the entry of the National Phase in the U.S. Since the Search Report was from the U.S. JPO or EPO search authorities, copies of these references should have been supplied to the USPTO under the trilateral agreement and are believed to be in the file of the above identified application and readily available to the Examiner.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty  
Registration No. 36,139

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**Date: October 20, 2005**

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SHEET 1 OF 1

**\*EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.  
Include copy of this form with next communication to applicant.



SHEET 1 OF 1

~~REVIEWING: Initial reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.~~

**EXAMINER:** Initial if reference considered, whether or not cited  
Include copy of this form with next communication to applicant.

Include copy of this form with next communication to applicant.

1 Application's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

**1** Applicant's unique citation designation number (optional). **2** Applicant is to place a check mark here if language foreign.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /L.M./

10/553845

JC09 Rec'd PCT/PTO 20 OCT 2005

SHEET 1 OF 1

**\*EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.  
Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /L.M./